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10531763 - GAU-1795

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10531763	
	Filing Date		2005-04-18	
	First Named Inventor	Susan D. Strothers		
	Art Unit	Unknown		
	Examiner Name	Unknown		
	Attorney Docket Number	H0004599.69957 US -4015		

U.S. PATENTS

Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages, Columns, Lines where Relevant Passages or Relevant Figures Appear
	1	6689254	B1	2004-02-10	Tokyo Electron Limited	Claims 1, 2, 15, 17, 19, 27, 32, 41
	2	5409590	A	1995-04-25	Tokyo Electron Limited	Claims 1 and 3
	3	5130005	A	1992-07-14	Tokyo Electron Limited	Claims 1, 6, 11, 15, 18, 21
	4	6340415	B1	2002-01-22	Applied Materials, Inc.	Claim 1, 21, 26, 28
	5	6955852	B2	2005-10-18	Tosoh SMD, Inc.	Claims 1, 2, 3
	6	6840427	B2	2005-01-11	Tosoh SMD, Inc.	Claims 1 and 14
	7	5487822	A	1996-01-30	Applied Materials, Inc.	All Claims
	8	5565071	A	1996-10-15	Applied Materials, Inc.	Claim, 1 and 9

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9	5595337	A	1997-01-21	Applied Materials, Inc.	Claims 1, 2, 3
10	5603816	A	1997-02-18	Applied Materials, Inc.	Claim 1
11	5433835	A	1995-07-18	Applied Materials, Inc.	Claims 1, 14, 21
12	5676803	A	1997-10-14	Applied Komatus Technology, Inc.	Claims 1, 7, 10, 11
13	5863397	A	1999-01-26	Taiwan Semiconductor Manufacturing Co. Ltd.	Claims 1, 5, 15
14	5985115	A	1999-11-16	Novellus Systems, Inc.	Claims 1-4, 5-8

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U.S.PATENT APPLICATION PUBLICATIONS

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1	10018858	DE	2001-10-25	Ardenne Anlagentech GmbH	Claim 1	<input type="checkbox"/>
2	01-132761	JP	1989-05-25	Fujitsu Ltd.		<input type="checkbox"/>

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Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
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Examiner Signature	/Jason Berman/	Date Considered	12/10/2008
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